

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>		08893917			
<b>Filing Date:</b>		11-Jul-1997			
<b>Title of Invention:</b>		REMOTE PLASMA CLEANING SOURCE HAVING REDUCED REACTIVITY WITH A SUBSTRATE PROCESSING CHAMBER			
<b>First Named Inventor/Applicant Name:</b>		KARL A. LITTAU			
<b>Filer:</b>		Matthew Temple Sarles/Cindy Bennett			
<b>Attorney Docket Number:</b>		AM2119/T2130			
Filed as Large Entity					
<b>Utility Filing Fees</b>					
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)	
<b>Basic Filing:</b>					
<b>Pages:</b>					
<b>Claims:</b>					
<b>Miscellaneous-Filing:</b>					
<b>Petition:</b>					
<b>Patent-Appeals-and-Interference:</b>					
<b>Post-Allowance-and-Post-Issuance:</b>					
<b>Extension-of-Time:</b>					
Extension - 3 months with \$0 paid	1253	1	1050	1050	

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>1050</b>